



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## BIB DATA SHEET

CONFIRMATION NO. 8996

<b>SERIAL NUMBER</b> 10/530,562	<b>FILING or 371(c) DATE</b> 04/07/2005 <b>RULE</b>	<b>CLASS</b> 117	<b>GROUP ART UNIT</b> 1792	<b>ATTORNEY DOCKET NO.</b> Q87267	
<b>APPLICANTS</b> Masahiko Hata, Tsuchiura, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/13067 10/10/2003 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-301059 10/15/2002 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /FELISA CARLA HITESHEW/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 1	<b>TOTAL CLAIMS</b> 14	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES					
<b>TITLE</b> Production method for thin-film crystal wafer, semiconductor device using it and production method therefor					
<b>FILING FEE RECEIVED</b> 1260	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		